

## Electronic Acknowledgement Receipt

EFS ID:	3215582
Application Number:	10690507
International Application Number:	
Confirmation Number:	6043
Title of Invention:	Method for manufacturing polycrystalline silicon thin film and thin film transistor fabricated using polycrystalline silicon thin film manufactured by the manufacturing
First Named Inventor/Applicant Name:	Ji Yong Park
Customer Number:	49455
Filer:	Hung H. Bui/Jennifer Oakley
Filer Authorized By:	Hung H. Bui
Attorney Docket Number:	1514.1032
Receipt Date:	28-APR-2008
Filing Date:	23-OCT-2003
Time Stamp:	11:39:18
Application Type:	Utility under 35 USC 111(a)

### Payment information:

Submitted with Payment	no
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### File Listing:

Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part/.zip	Pages (if appl.)
1		IDS_04-28-08.pdf	6153404 b02333a1ca50598785149910d98e10f8 9bcb199b	yes	70

Multipart Description/PDF files in .zip description			
Document Description	Start	End	
Information Disclosure Statement Letter	1	4	
Information Disclosure Statement (IDS) Filed	5	5	
Foreign Reference	6	42	
Foreign Reference	43	67	
NPL Documents	68	70	

**Warnings:**

**Information:**

Total Files Size (in bytes):	6153404
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**New Applications Under 35 U.S.C. 111**

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

**National Stage of an International Application under 35 U.S.C. 371**

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.

**New International Application Filed with the USPTO as a Receiving Office**

If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.